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Date of signature and deposit - October 10, 200/

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Henry J. Simon et al

Serial No.: 09/943,696

Filed: August 31, 2001

For: METHOD OF MEASURING
SURFACE PLASMON RESONANCE
USING INTERFERENCE
STRUCTURE OF REFLECTED
BEAM PROFILE

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Croup Art Unit:

Attorney Docket 1-21526

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INFORMATION DISCLOSURE STATEMENT IN ACCORDANCE WITH 37 CFR §1.97

Honorable Sir:

Pursuant to 37 C.F.R. 1.97(b), record is hereby made of information that the Patent Office may wish to consider in connection with its examination of the above-identified application. Enclosed is a list of such information along with a legible copy of each document.

Respectfully submitted,

Shital A. Shah

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